



AHEAD OF WHAT'S POSSIBLE™

Using MEMS Accelerometers for Condition Monitoring

ED SPENCE

Marketing Manager

Industrial Sensors Business Unit

09/21/2016

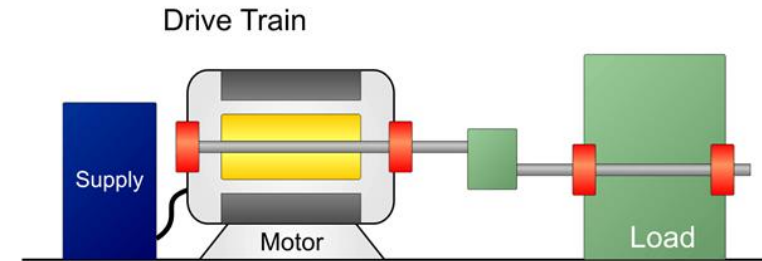
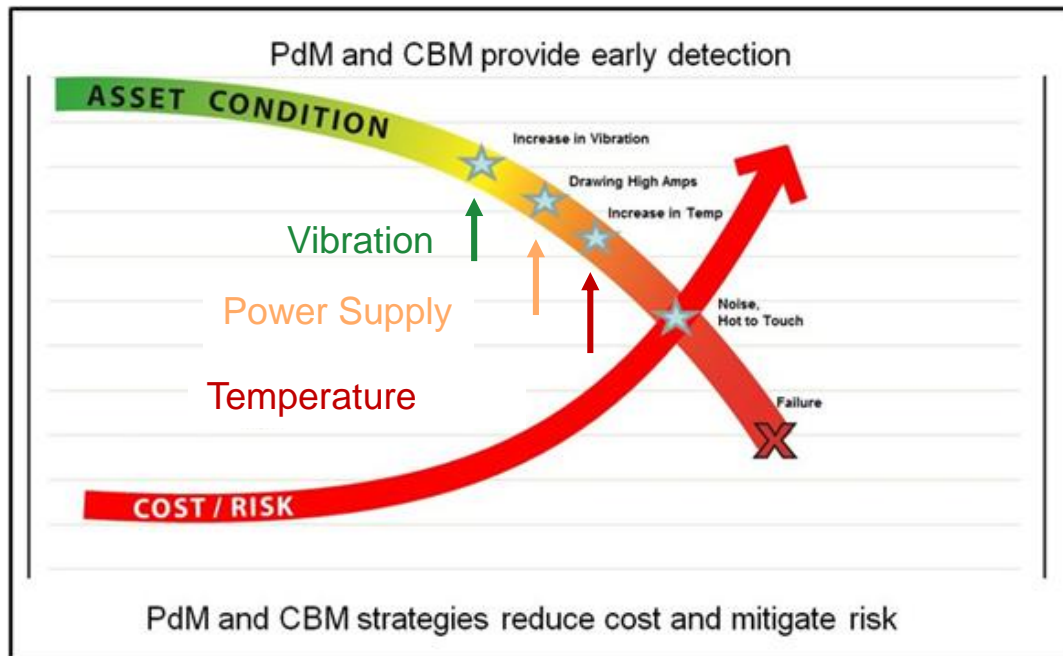


Agenda

- ▶ Brief overview of Condition Based Monitoring (CBM) methodologies
- ▶ Intrinsic properties of MEMS accelerometers
- ▶ Review of the performance history of MEMS accelerometers
- ▶ A glimpse into how MEMS is already impacting CBM

CBM Methodologies

Timely Indicators of an Emerging Problem



Supply	Power Quality	EPVA (Voltage)	
Mec. Imbalance or Misalignment	MCSA	Vibration	EPVA
Insulation Faults	Partial Discharge	EPVA	
Stator Electrical Imbalance	EPVA	MCSA	Power Quality
Broken Bars	MCSA	EPVA and IPSA	
Bearing Faults	Vibration	Wavelet on Current	MCSA, EPVA and IPSA
Coupling and Load Mechanical Failures	Vibration	MCSA, EPVA and IPSA	

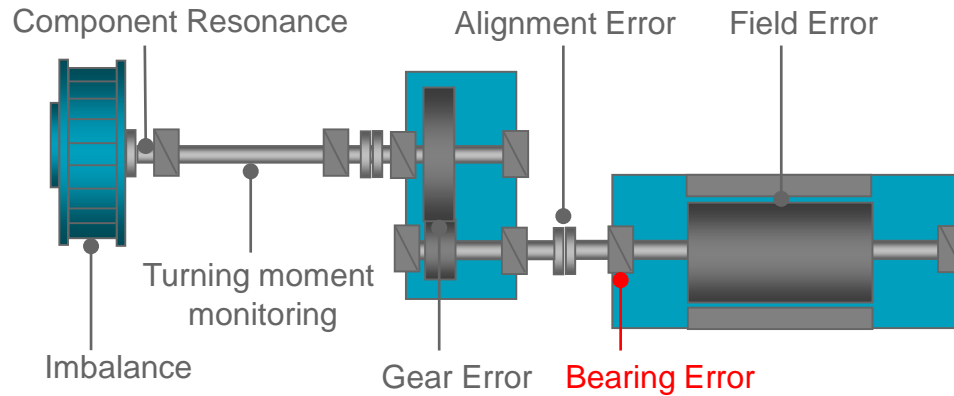
Significance: High Medium Low

Analysis of Vibration

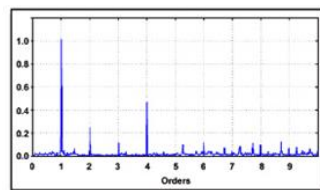
Pump / Fan

Gear Box

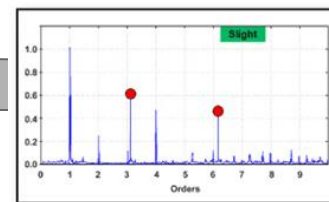
Drive



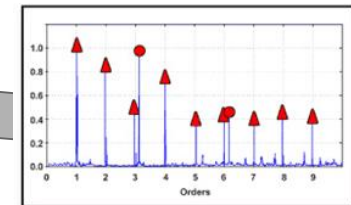
- Mechanical system
- Signal analysis techniques and algorithms apply



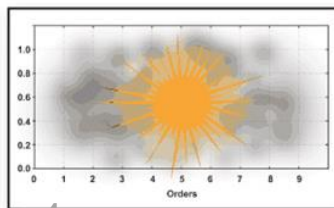
1. Early bearing wear in the high range only



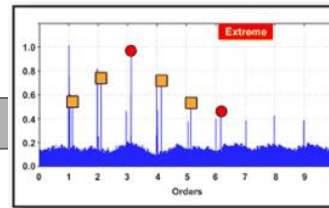
4. Harmonic of bearing tone



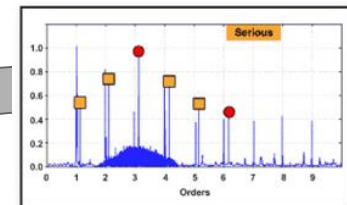
5. Looseness—harmonics of motor shaft



9. Bearing failure

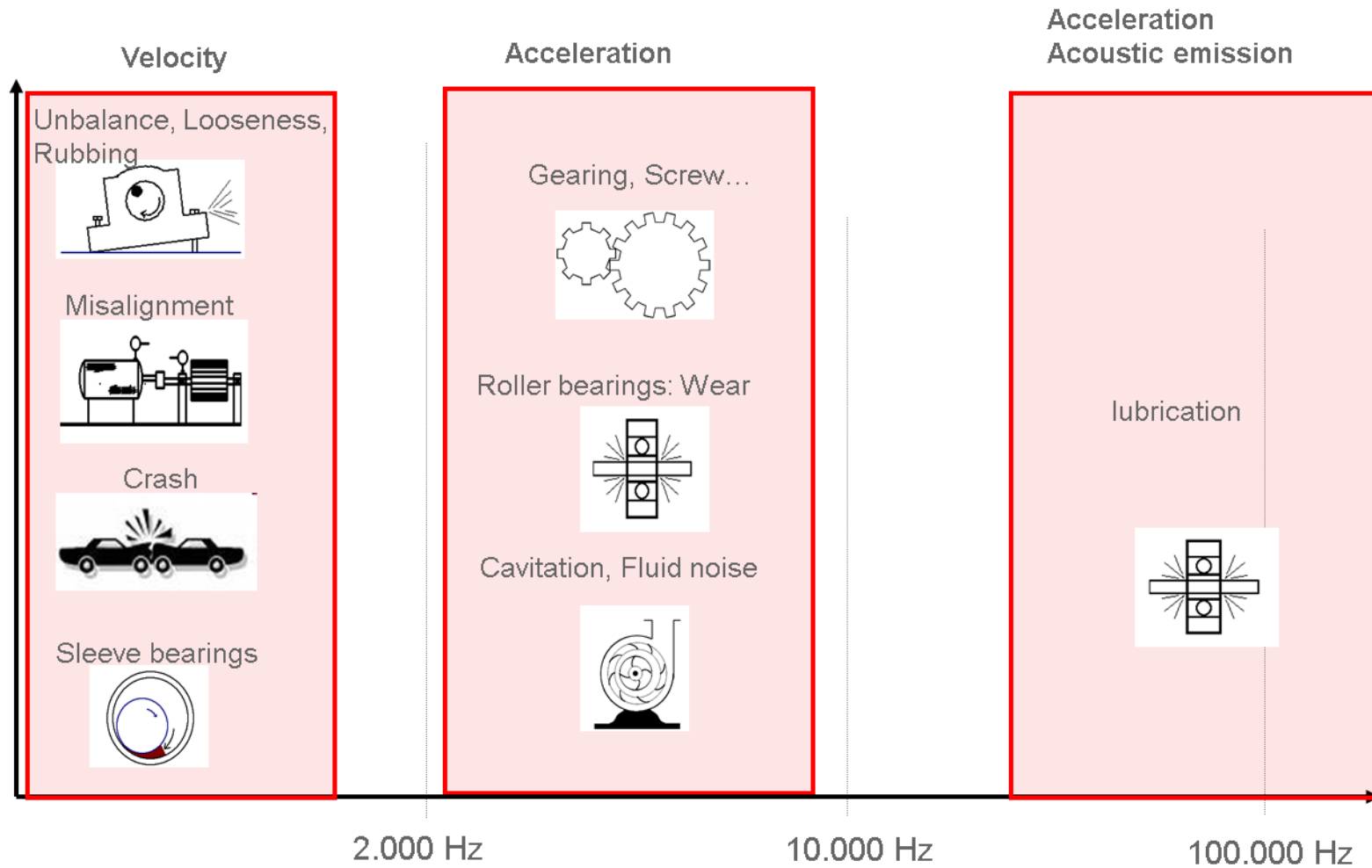


8. Increase of entire noise floor



7. Noise hump near bearing tone

Machine Faults and Vibration Frequencies

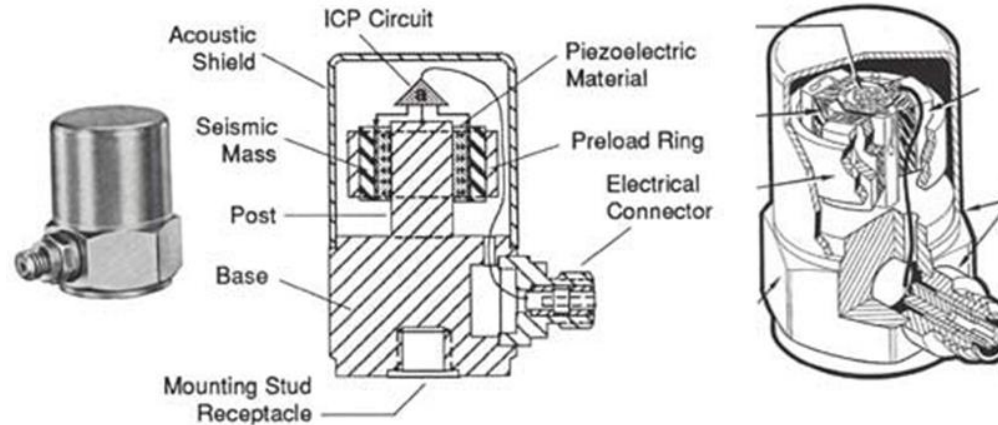


General machine vibrations (ISO 10816)
10Hz ... 1000 Hz or 2Hz ... 1000 Hz

Mechanical wear
2000 Hz ... 6000 Hz

Courtesy: IFM Efector

Condition Monitoring Accelerometers Today



- Low noise over very high frequency operation
- Industrial power supply levels (e.g. 24V)
- Assembled mechanical technology – manual intensive manufacturing techniques
- Sensitivity changes with shock or drift (requires recalibration if dropped)
- Charge output device SNR typically drops at lower frequencies
- Limited self test
- Not particularly easy to integrate into a sub-system



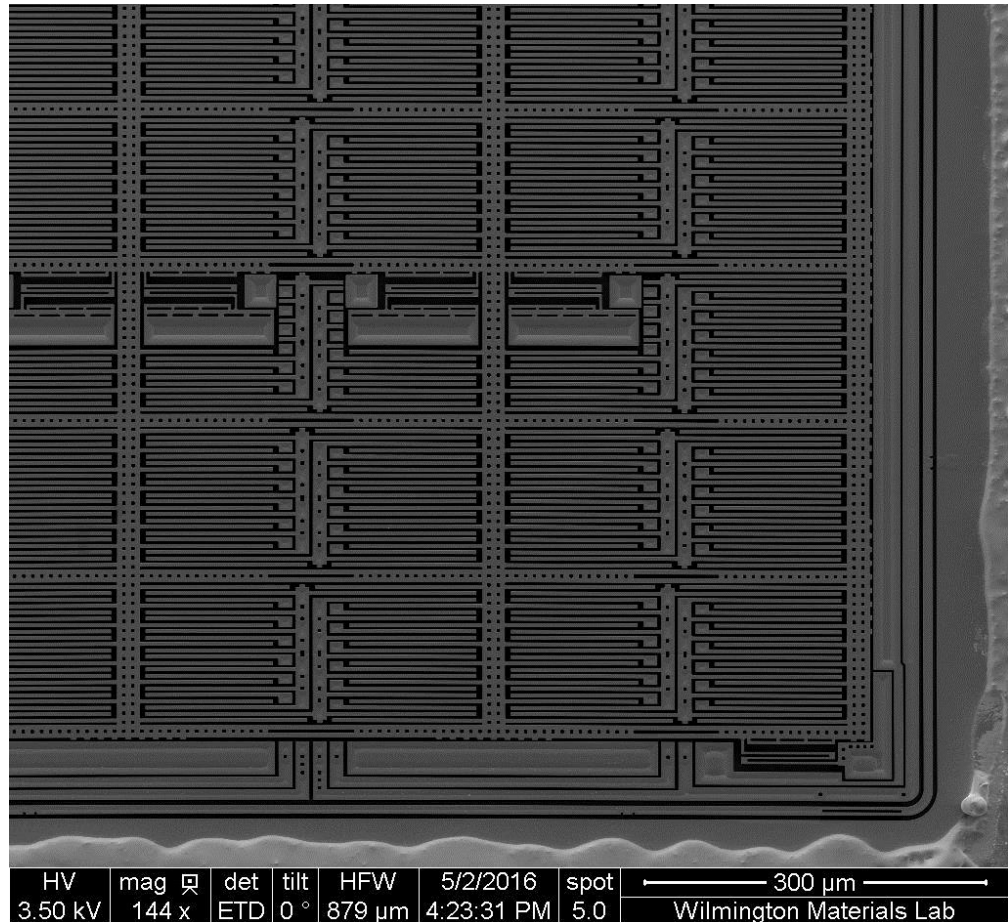
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MEMS Accelerometers – Intrinsic Properties

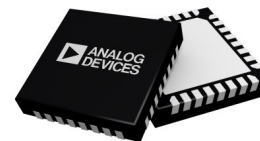
MEMS Accelerometers for Condition Monitoring

Intrinsic Properties

- ▶ Stable sensitivity
- ▶ DC Response
- ▶ Shock tolerant
- ▶ Electro-static self test
- ▶ High reliability
- ▶ Low power
- ▶ Highly integrated
- ▶ Small size
- ▶ Scalable manufacturing



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Intrinsic Properties of MEMS Accelerometers

Stable Sensitivity

Level 1: Parameter trend monitoring

- Comprehensive
- Long-term
- Less-skilled personnel



Machine monitoring

Vibration load
Bearing condition

Parameters

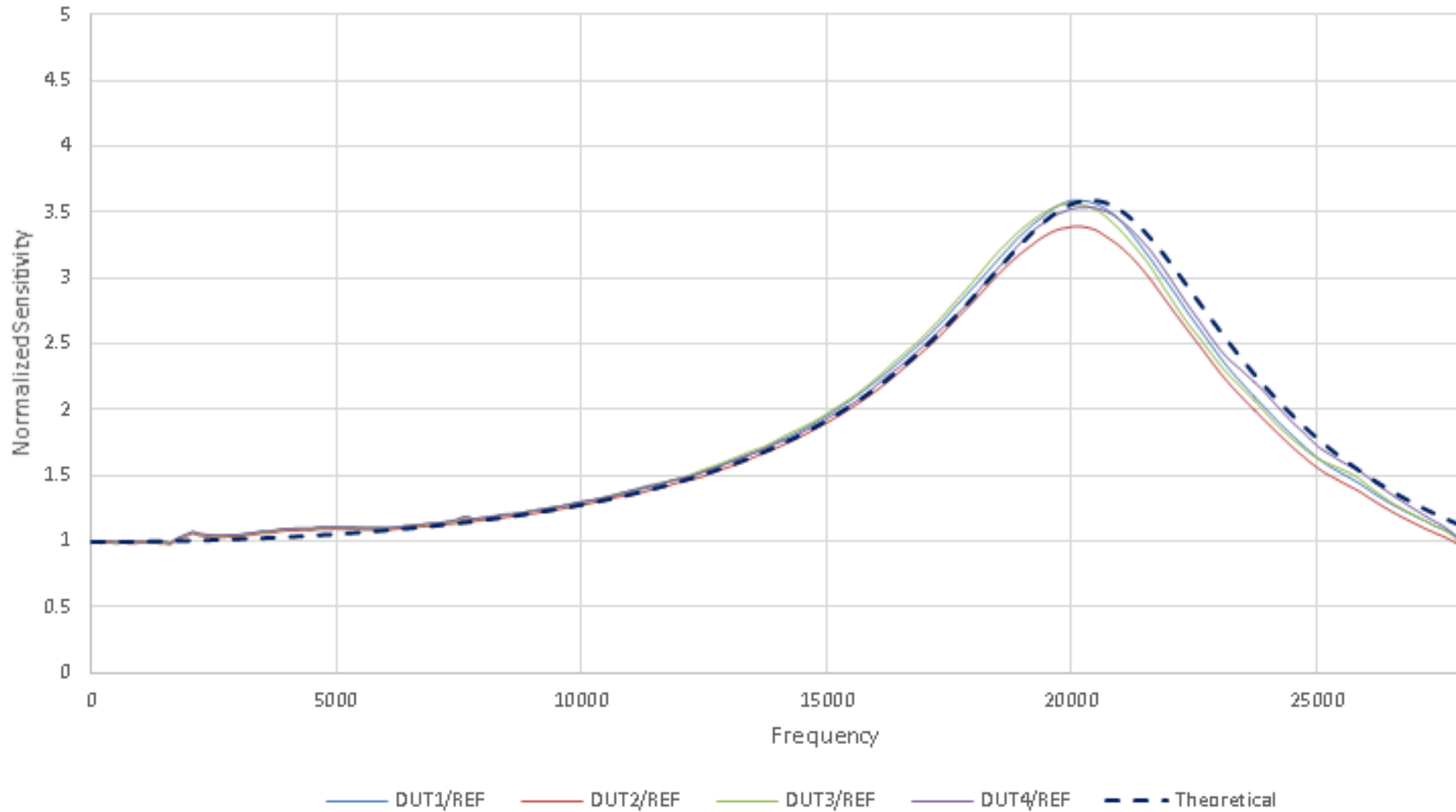
Vibration strength, displacement, acceleration
Shock pulse for bearing evaluation
Temperature
RPM
Pump cavitation

- ▶ Integrated acceleration (velocity) is tracked over time
 - A baseline is established and changes to nominal behavior are monitored
- ▶ Frequently cited problems with mechanical accelerometers
 - Sensitivity can shift over time and temperature, or when subject to shock
- ▶ Stable sensitivity introduces less error
 - MEMS accelerometer sensitivity typically remains within $\pm 5\%$ over the full temperature range

Frequency response at 25C

FSR $\pm 50g$

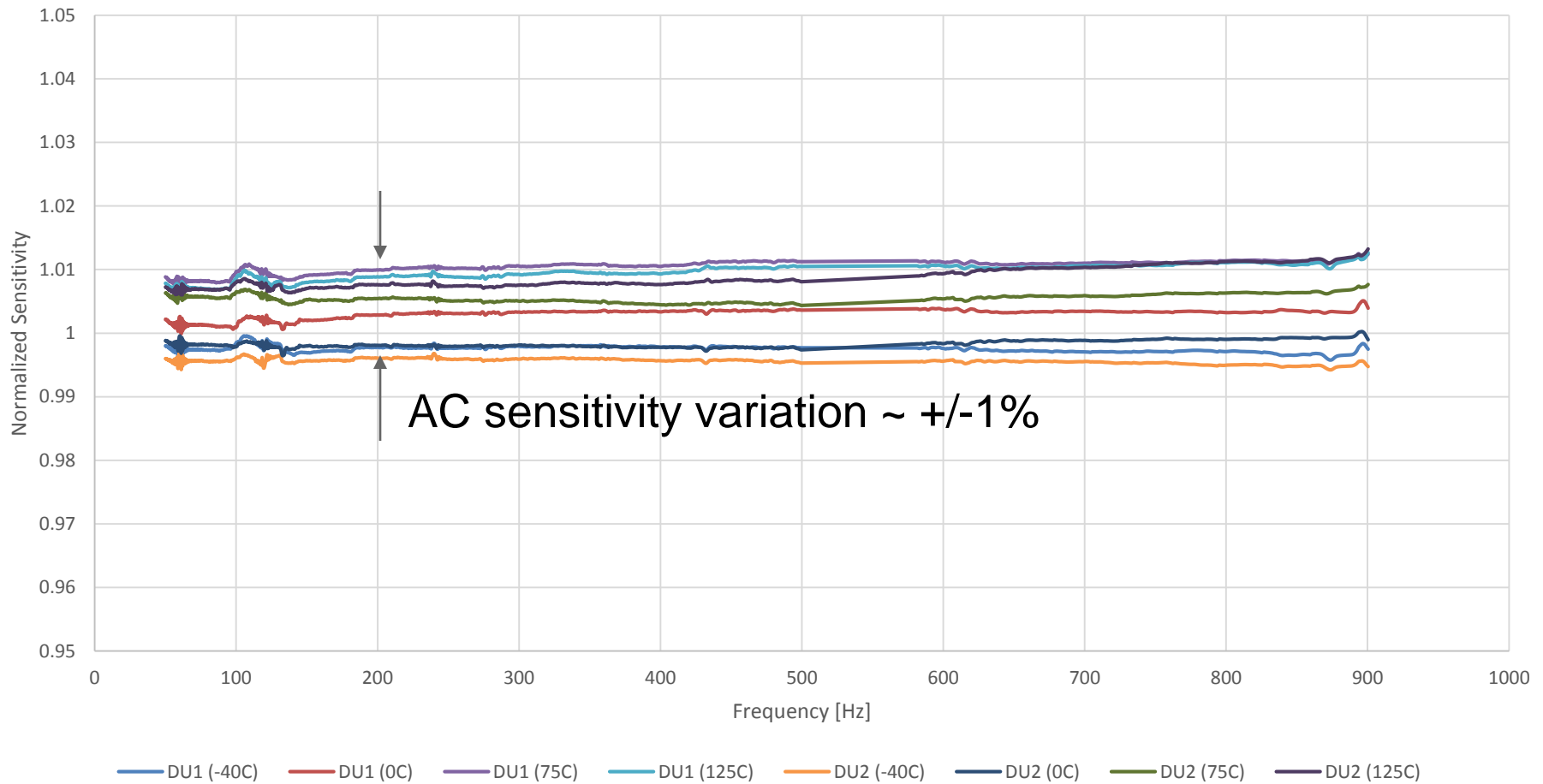
frequency response - 10g Sine



Frequency response v. temperatures

25g sine

low frequency response at various temperatures



Intrinsic Properties of MEMS Accelerometers

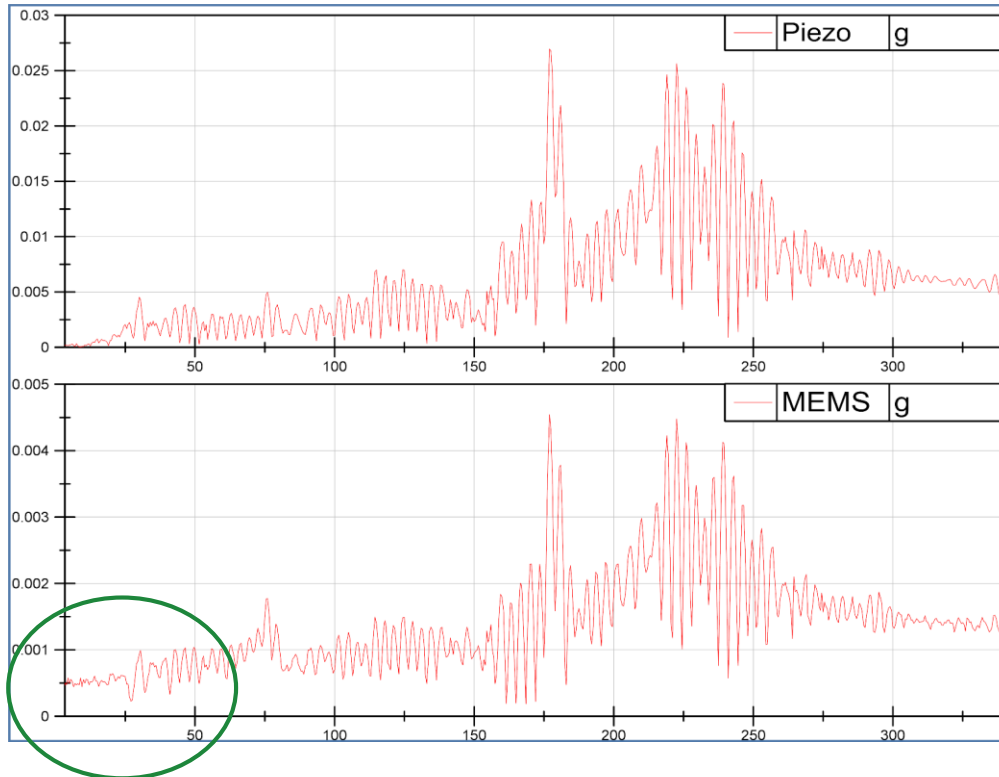
DC Coupled, Low Resistance Output

- ▶ Low rotation rate equipment integrates velocity down to 0.1Hz
- ▶ In addition, low resistive output means faster recovery from saturation
- ▶ Frequency response can be tailored by the user with external components



Intrinsic Properties of MEMS Accelerometers

DC Response



- ▶ Side by side comparison of MEMS and PZT
- ▶ Accelerometers subjected to a mild shock while recording data and computed the FFT
- ▶ The results show the MEMS accelerometer resolving down to DC...

Intrinsic Properties of MEMS Accelerometers

Low Power Electronics

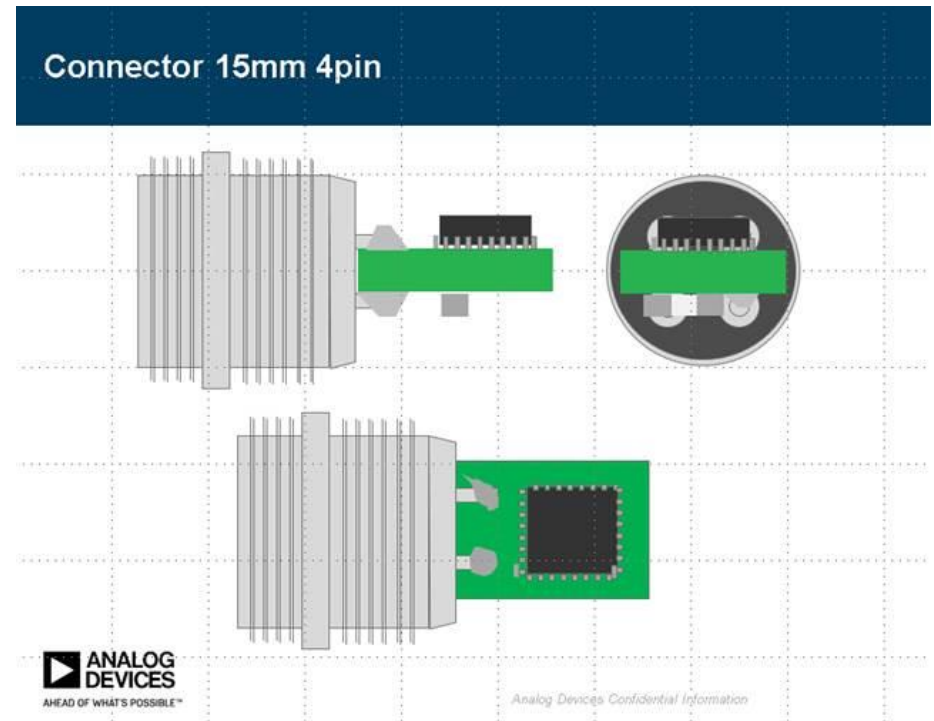
- ▶ Single supply signal conditioning electronics
 - Supply voltages of +5V or less replace high industrial voltages
 - Easier to interface
- ▶ Lower power sensor electronics extend battery life
- ▶ Lower cost power management BOM
 - Broader selection of components
- ▶ Smaller form factors
 - Dominated by battery size, antenna



Intrinsic Properties of MEMS Accelerometers

Small Size

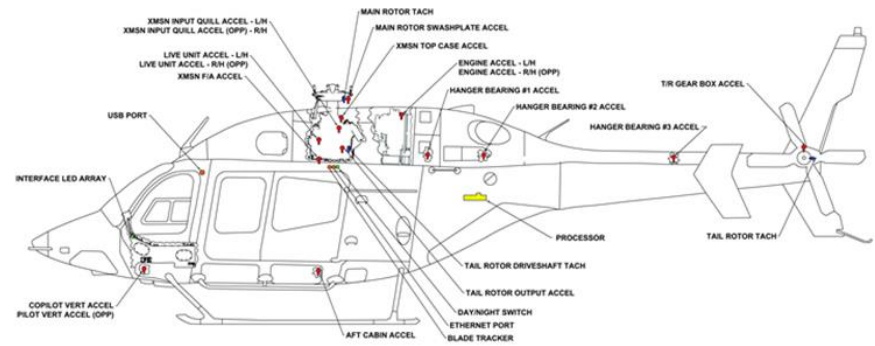
- ▶ Embedding in the machine or asset
- ▶ Integration within standard through-hole package is possible
- ▶ +5V Analog interface supported by most DAQs or Controllers
 - Other interface modes are possible
- ▶ Do optimized locations lead to higher quality transmission of mechanical vibration?



Intrinsic Properties of MEMS Accelerometers

Low Weight

- ▶ A high performance accelerometer in 6 x 6 mm LCC weighs less than 1 gram
- ▶ Digital interface can reduce cable costs and weight
 - Single supply signal conditioning enables higher integration levels
- ▶ Airborne applications will benefit from reduced fuel costs

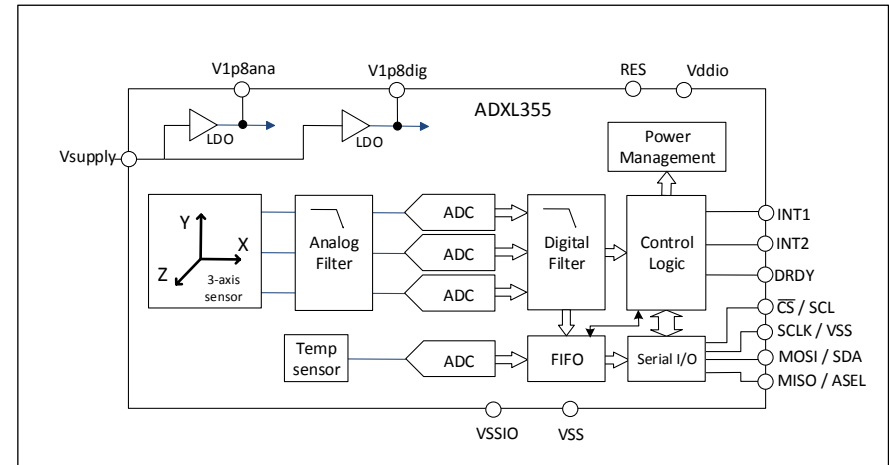


Accelerometers used as part of a HUMS monitoring system

Single Supply Signal Conditioning Electronics

Enabling Enhanced Features

- ▶ Electro-static self test
 - Deflection of the MEMS movement transmitted through the full signal chain
- ▶ Over-range indicator
 - Quickly assess cause of 'ski slope'
- ▶ Integrated ADC and Digital interface
 - Higher EMI immunity
 - Lower cost cables
 - Digital filtering
 - Memory buffers





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MEMS Accelerometers – Performance History

High Frequency MEMS Accelerometer Vintage 2009

- ▶ ± 70 g to ± 500 g Full Scale Range
- ▶ 22 kHz resonant frequency
- ▶ 2.5mA typical power supply current
- ▶ Integrated self-test
- ▶ -40C to +125C
- ▶ 5 x 5 mm 8-pin LCC
- ▶ 4mg / $\sqrt{\text{Hz}}$ noise density
(500mg (RMS) in 10kHz)

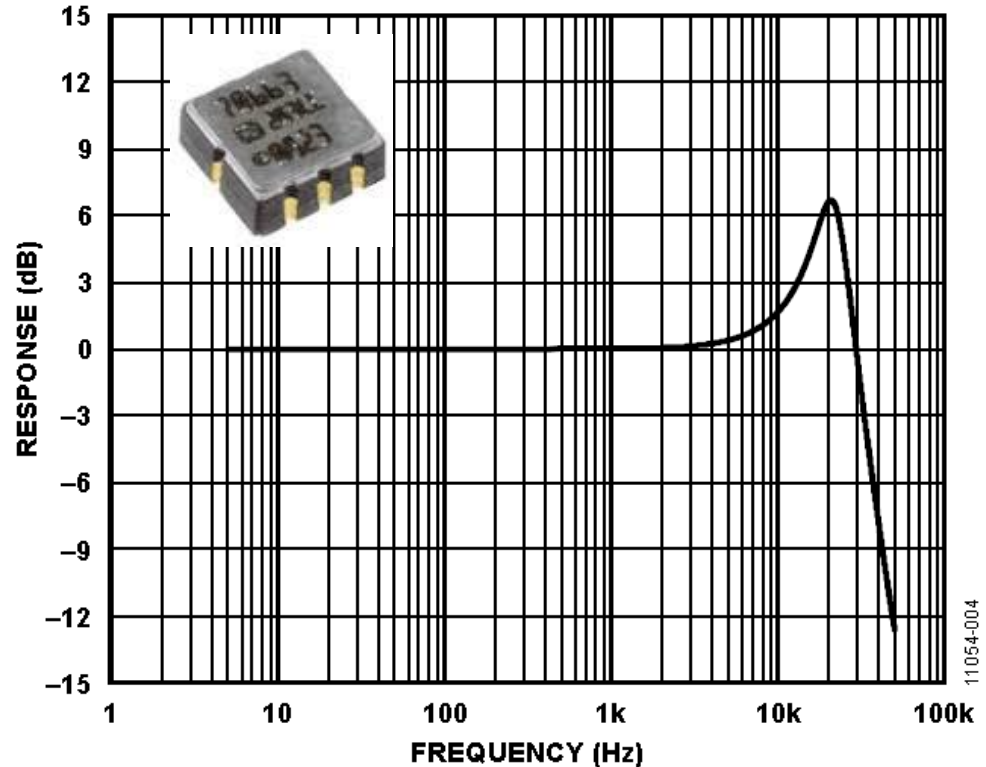
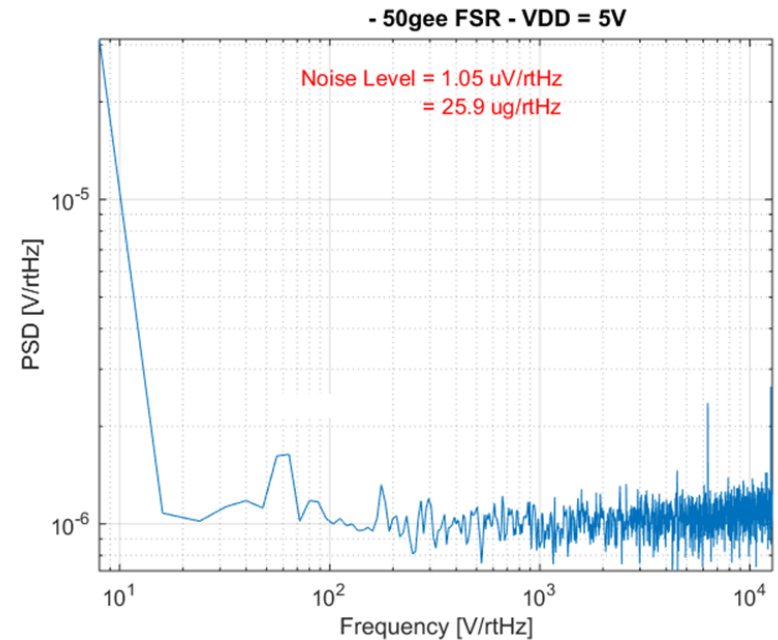


Figure 4. [ADXL001](#) Frequency Response

Upgraded Accelerometer Performance in 2016

Are MEMS Accelerometers Finally Ready for Mainstream CBM?

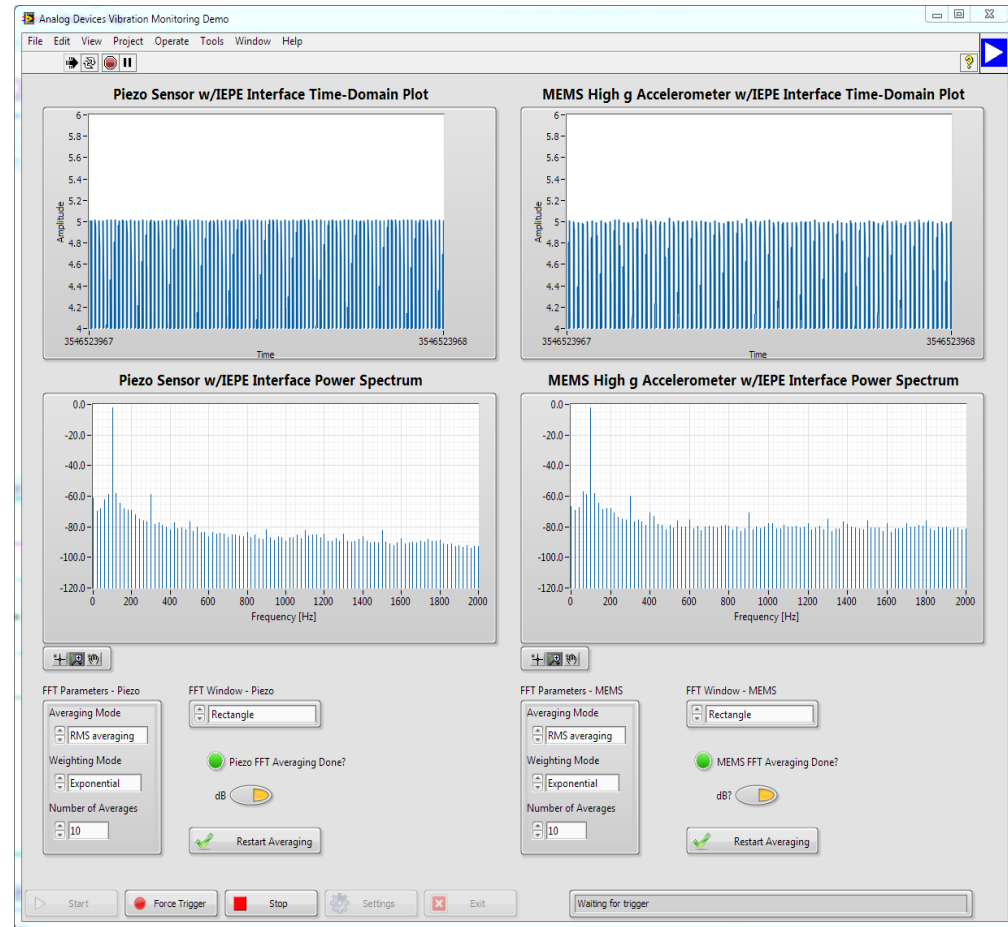
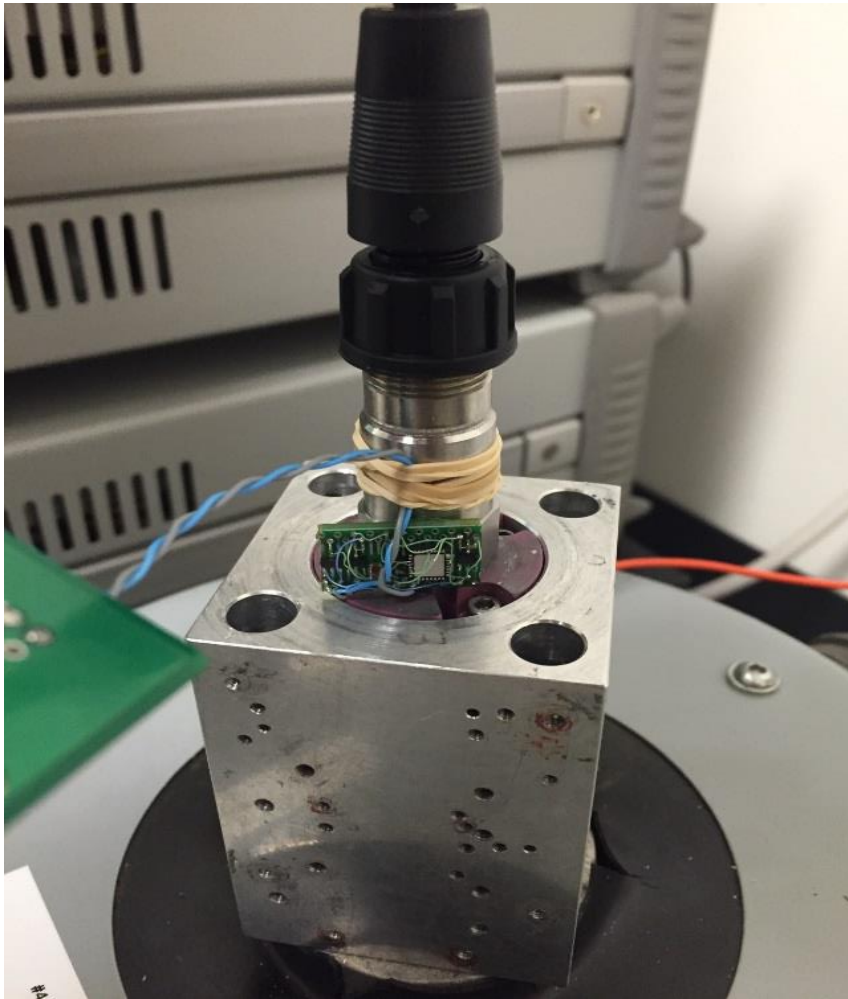
	Gen 1	Gen 2
FSR	± 70 g to ± 500 g	± 50 g to ± 100 g
F0	22kHz	21kHz
Supply Current	2.5mA	1.0mA
Self Test	Yes	Yes
Temp Range	-40C to +125C	-40C to +125C
Package	5 x 5 mm 8 pin LCC	5 x 5 mm 32 pin LFCSP
Noise Density	4000 μ g / $\sqrt{\text{Hz}}$	<30 μ g / $\sqrt{\text{Hz}}$



2 orders of magnitude drop in RMS noise
from 500mg to 3mg
(1 to 10kHz)

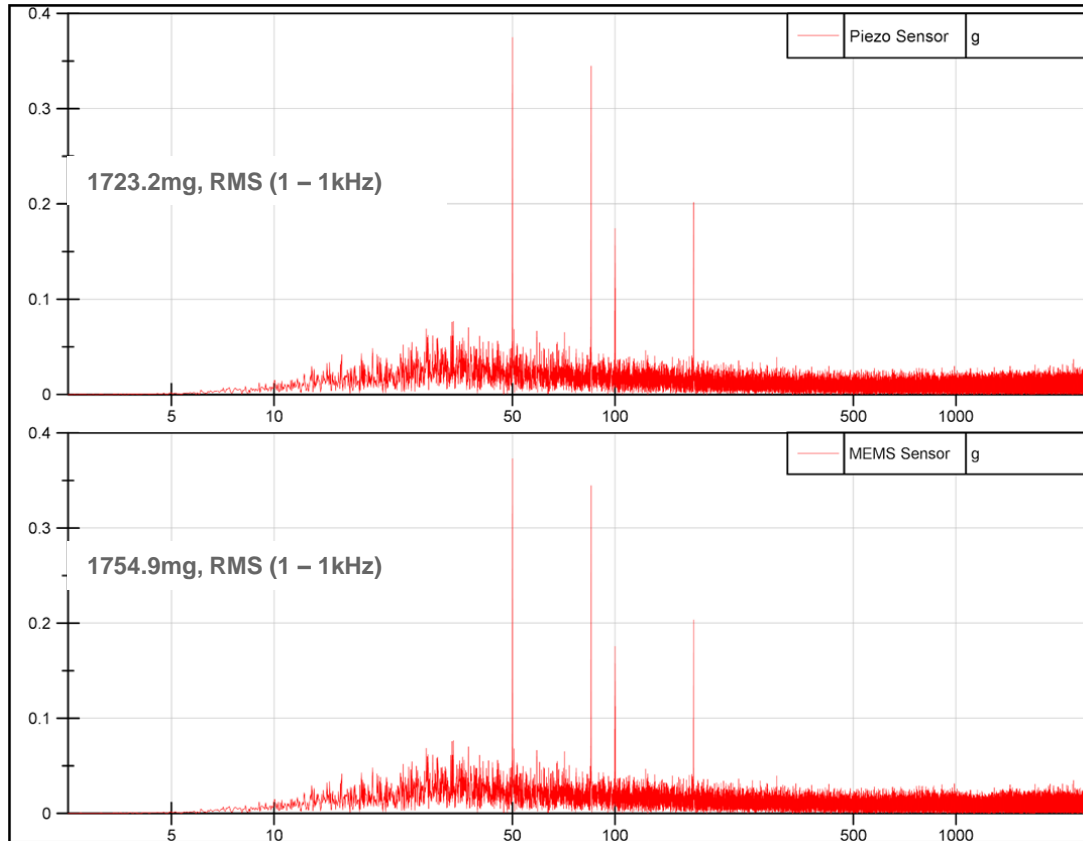
Accelerometer Technology Comparison

Test Set Up to Compare Commercially Available PZT to a New 21kHz MEMS Accelerometer



Motor Misalignment Simulation¹

Harmonics Added to the Stimulus



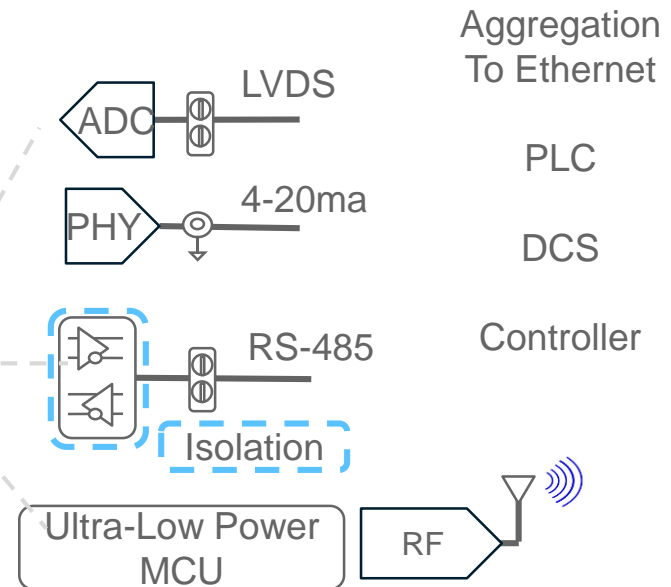
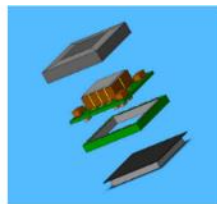
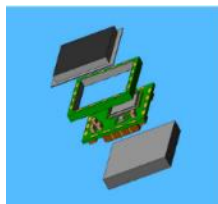
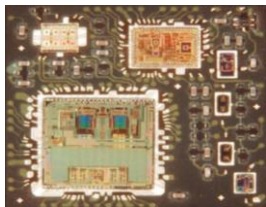
R B Randall, Vibration-based Condition Monitoring, 2011
John Wiley & Sons, Hoboken, NJ, Page 34.

- ▶ Comparable performance over 10kHz....
- ▶ PZT is 30mg, RMS lower (1 – 1000Hz)
 - 1.7% delta between sensors

MEMS Accelerometers for CBM – Implications and Future Developments

MEMS Accelerometers Enable Highly Integrated Solutions

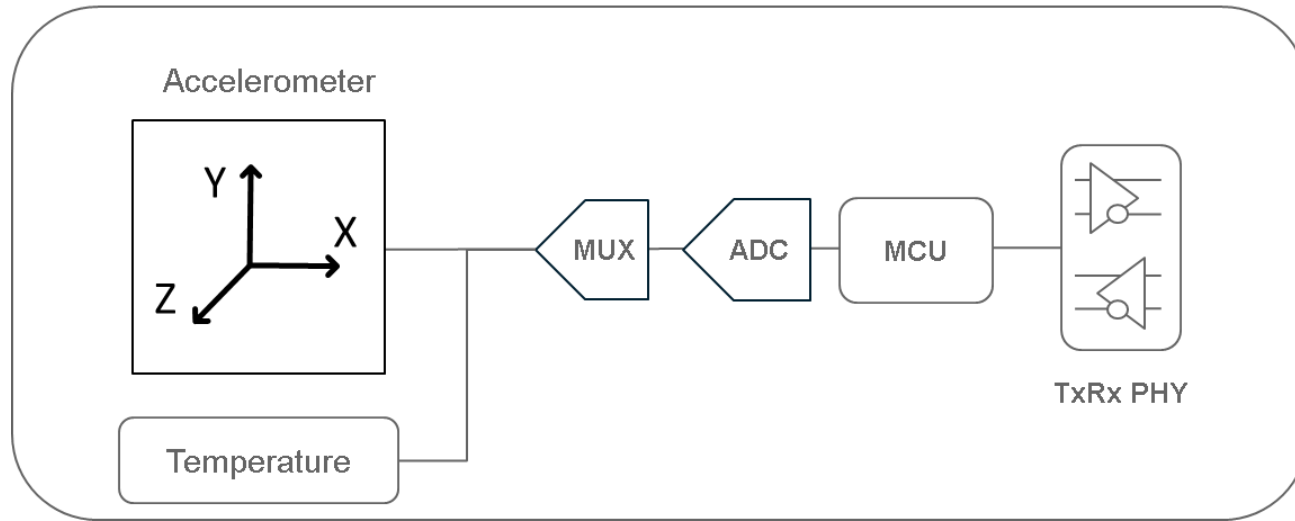
- High frequency accelerometers
- Portfolio of signal conditioning solutions
 - ADCs
 - MCUs
 - Interface PHY
- SIP manufacturing capability



System-in-Package (SIP) Manufacturing

Embedded, Connected, Smart Sensors for Condition Monitoring

Example Concept



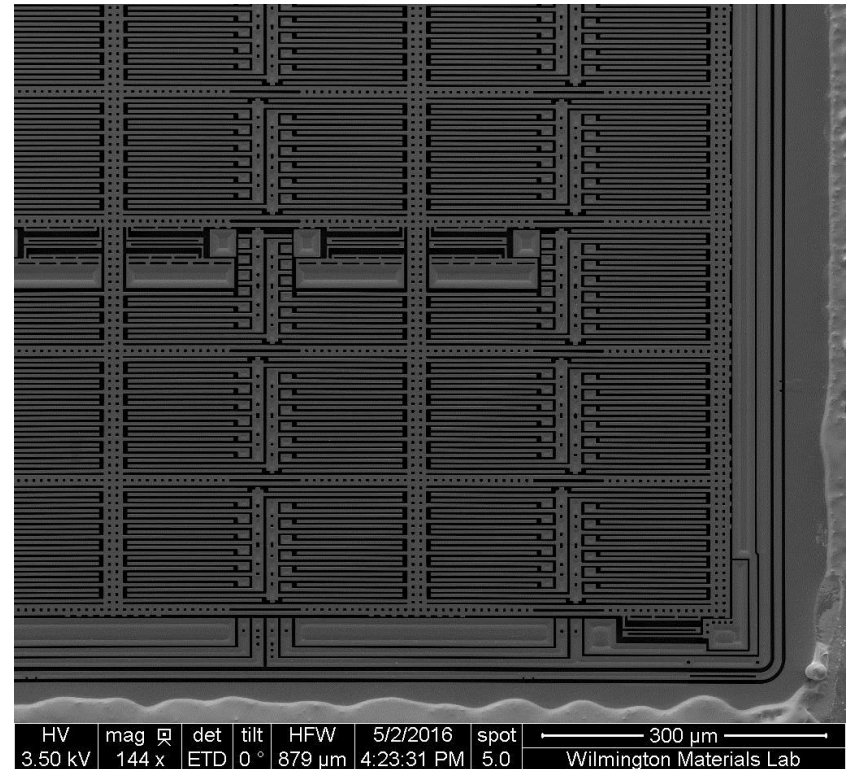
- ▶ High frequency, low noise MEMS accelerometers
- ▶ Low power, +3V signal chain
- ▶ Applications processing
- ▶ Industrial interface (e.g. RS-485)
- ▶ 105C operation
- ▶ Less than 125 mm² footprint

Summary

MEMS Accelerometers offer compelling, intrinsic attributes that can change the way CBM is practiced today.

Making exciting new products possible -

- Smart sensors
- Wireless / Portable
- Embedded solutions



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